PTO/SB/08A (07-05)

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Sheet 1

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known			
Application Number	10/800,470		
Filing Date	03/15/2004		
First Named Inventor	ZHU		
Art Unit	2891		
Examiner Name	ANYA		
Attorney Docket Number	DB001092-001		

			U. S. PATENT	DOCUMENTS	
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ^{2 (f known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		^{US-} 6,573,156 B1	06-03-2003		
	ļ	^{US-} 2003/0119275 A1	06-26-2003		
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		FORE	IGN PATENT DOCU	MENTS		
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages	- 6
,		Country Code ³ Number ⁴ Kind Code ⁵ (if known)	MM-DD-YYYY		Or Relevant Figures Appear	T
		DE 100 65 686 A1	12-29-2000			\checkmark
		DE 102 46 053 A1	10-02-2002	; ; 		\checkmark
		DE 101 22 845 A1	05-11-2001			
		JP 2003086539	03-20-2003			
		WO 01/20948A2	03-22-2001			

Examiner	· · · · · · · · · · · · · · · · · · ·	: Date		
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STATEMENT BY APPLICANT Art Unit 2891 (Use as many sheets as necessary) **Examiner Name ANYA** Attorney Docket Number Sheet DB001092-001 2 of

	NON PATENT LITERATURE DOCUMENTS	
Examiner Cite Initials* No.		T ²
1	Y.B. NING, A.W. MITCHELL, R.N.TAIT, "Fabrication of a silicon micromachined capacitive microphone using a dry-etch process," Vol. 53, no. 1, 1996,	
	pp. 237-242, Elsevier Sequoia S.A., Lausanne, CH	
2	J. BAGDAHN, H. KNOLL, M. WIEMER, M. PETZOLD, "A new approach for handling and transferring of thin semiconductor materials," Vol. 9, no. 3,	
	2003, pp. 204-209, Microsystem Technologies Springer-Verlag, Germany	

Examiner	Date	
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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